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(ISPHOA 2014)**

14-15 October 2014
Sanur, Bali, Indonesia

Editor
Aulia Nasution

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Department of Engineering Physics - FTI
Institut Teknologi Sepuluh Nopember (Indonesia)

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The Optical Society (United States)
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Local Density of Optical States of an Asymmetric Waveguide Grating at Photonic Band Gap Resonant Wavelength

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ABSTRACT

We have investigated the characteristics of local density of optical states (LDOS) at photonic band gap resonant wavelength of an asymmetric waveguide grating based on Green's function formulation. It is found that the LDOS of the considered structure exhibits different characteristics in its localization between the upper and lower resonant wavelengths of the corresponding photonic band gap edges.

Keywords: Local density of optical states, waveguide grating, Green's function method, resonant state.

1. INTRODUCTION

In recent years, the asymmetric waveguide grating (WG) structure in the form of asymmetric corrugated slab waveguide has been intensively used in integrated optical device for sensor application [1]. The existence of photonic band gap (PBG) in an asymmetric WG, where light in certain range of wavelength cannot propagate, has been well studied [2]. The wavelength variation of resonant wavelengths at PBG edges are usually considered in sensor device due to its ability to detect the change of refractive index of the surrounding material.

Recently also, it was reported the characteristics of energy confinement, scattering loss and group velocity of asymmetric WG at resonant states of the corresponding PBG [3]. It was shown that for increasing number of teeth, the group velocity and energy confinement can be enhanced significantly without affecting the scattering loss on both upper and lower resonant states. In the meantime, groove depth variation exhibited different characteristics between both resonant states. It is well known that the number of teeth as well as groove depth that lead to the variation of the corresponding parameters affect significantly its sensitivity.

On the other hand, it is well known that one of the important properties of optical structure is its ability to accommodate photon eigenmodes at specific location inside the asymmetric WG. This property is represented by the so called local density of optical states or LDOS. There are several ways to calculate LDOS e.g. [4, 5, 6]. One of them is through Green's function method in the form of Dyson formulation [6]. In this method the corresponding LDOS can be calculated directly without calculating the electromagnetic field first as needed in the method given in ref. [4,5]. Unlike finite-difference scheme, this method does not need boundary condition.

Following the results of ref. [3], in this report we discuss the characteristics of LDOS of the associated asymmetric WG structure. Similar to that report, we employ the same Green's function method to calculate the related LDOS. We will discuss the dynamical characteristics of LDOS of the considered asymmetric WG with respect to the variation of number of teeth and groove depth showing the different behavior between the upper and lower resonant states.

2. ASYMMETRIC WAVEGUIDE GRATING STRUCTURE

We consider an asymmetric WG structure similar to what was discussed previously in ref. [3]. The corresponding structure is a three layer system consisting of a cladding with $n_{clad} = 1$, corrugated slab dielectric waveguide of thickness $h = 160 \text{ nm}$ with $n_{slab} = 1.98$, and substrate of $n_{sub} = 1.44$, while the grating period is set to $\Lambda = 200 \text{ nm}$. We consider the TE mode electric field illuminated from the left side. In this mode, the associated Green's function is a scalar function [6].

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Given in Fig. 1 is the sketch of corresponding asymmetric WG in which the corrugated section is only at one side of the slab waveguide. Here, we denote the number of teeth by N and g for the groove depth as parameters to be varied.

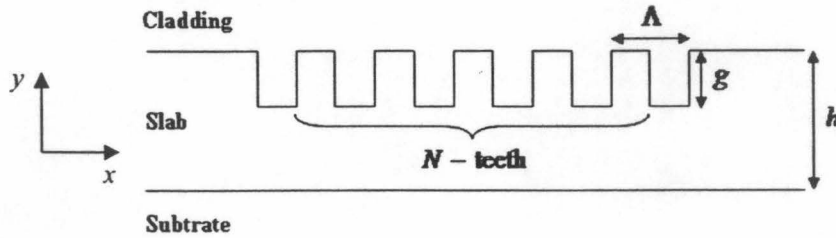


Fig. 1 Sketch of asymmetric waveguide grating

3. GREEN'S FUNCTION FORMULATION

We begin the calculation of Green's function $G(r, r')$ of the corresponding asymmetric WG by finding out the background Green's function $G^B(r, r')$, namely the Green's function of three layer system without corrugated section. The detailed calculation for this function can be found in ref. [6]. After constructing $G^B(r, r')$, the function $G(r, r')$ can then be calculated from the following equation:

$$G(r, r') = G^B(r, r') + \int_A G^B(r, r'') k_0^2 \Delta \epsilon(r'') G(r'', r') dA'' \quad (1)$$

Here $r = (x, y)$ and $r' = (x', y')$ denoting the observation point and dipole position respectively, while $\Delta \epsilon$ representing the perturbation in the form of permittivity contrast between background and corrugated section. The symbol k_0 is the vacuum wavenumber, while A is the computational domain. Having the Green's function (1) at hand, one can calculate it based on the following discrete form:

$$G_{ij} = G_{ij}^B + \sum_{i=1, j=1, i \neq k, j \neq k}^P G_{ik}^B k_0^2 \Delta \epsilon_k \Delta A_k G_{kj} + M_i k_0^2 \Delta \epsilon_i G_{ij} - L \frac{\Delta \epsilon_i}{\epsilon_B} G_{ij} \quad (2)$$

where M and L are parameters to handle singularity [6]. In principle, Eq. (2) can be solved iteratively namely by adding the perturbation one by one into the background structure. From this Green's function one can calculate the corresponding electric field as follows:

$$E(r) = E^B(r) + \int_A G(r, r') k_0^2 \Delta \epsilon(r') E^B(r') dr' \quad (3)$$

where $E^B(r)$ is the fundamental mode of the slab waveguide.

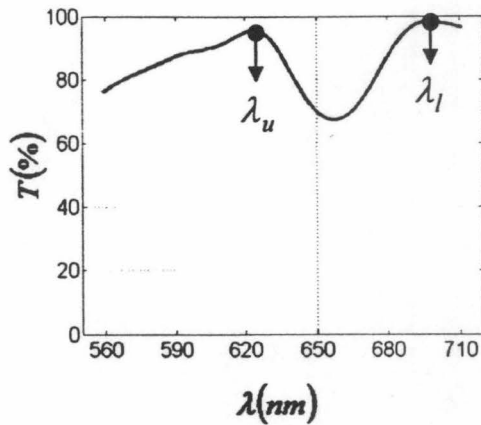
To calculate all these we define the computational domain as follows: the left and right boundaries in x -direction is $(x_l, x_r) = (0, 8) \mu m$, while the bottom and top boundaries in y -direction $(y_b, y_t) = (-40, 200) nm$. In the mean time the meshes are set to $\Delta x = 20 nm$ and $\Delta y = 10 nm$. All these computational parameters are similar to that used in ref. [3].

4. LDOS CHARACTERISTICS

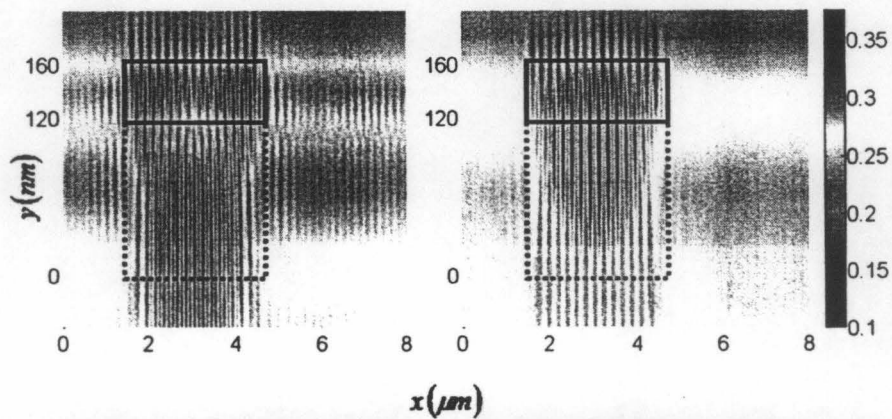
After findings the function $G(r, r')$, we can now calculate the LDOS using the following dimensionless definition [3, 7]:

$$\rho(r) = \frac{\text{Im}[G(r, r)]}{\text{Im}[G^B(r, r)]} \quad (3)$$

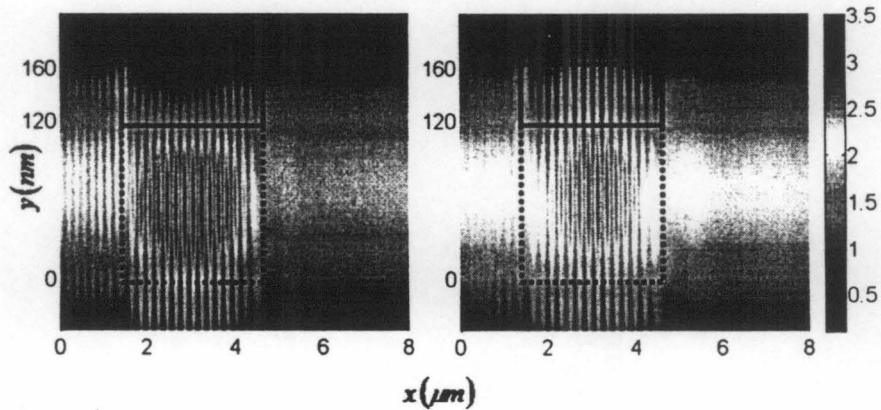
This quantity describes the number of photon eigenmode available between λ to $\lambda + d\lambda$ in specific position r , where λ denotes wavelength.



(a)



$x(\mu m)$



$x(\mu m)$

(b)

(c)

Fig. 2 (a) Transmittance of PBG of a specific asymmetric WG with $N = 14$ and $g = 40 \text{ nm}$. The left solid-dot denotes the upper resonant with shorter wavelength, while the right solid-dot represents the lower resonant with longer wavelength. (b) LDOS contour (top panel) at upper resonant with $\lambda_u = 624 \text{ nm}$ and (c) at lower resonant with $\lambda_l = 697 \text{ nm}$, with the corresponding electric field (bottom panel). Corrugated area is inside the box with solid-line boundary, while box with dotted-line boundary is the uncorrugated area.

Depicted in Fig. 2 is an example of PBG of a specific asymmetric WG structure discussed previously in ref. [3] with $N = 14$ and $g = 20 \text{ nm}$, along with upper and lower resonant wavelengths, and the corresponding LDOS which is the main focus of this discussion.

It is clearly shown in the figure that both resonant exhibit different characteristics. For the upper resonant, the LDOS is mostly localize in the uncorrugated area, while for the lower resonant the localization occurs both in uncorrugated as well as corrugated areas. This phenomenon is consistent with the fact that the related electric fields are also localized in more or less the same areas for both cases as shown in the figure.

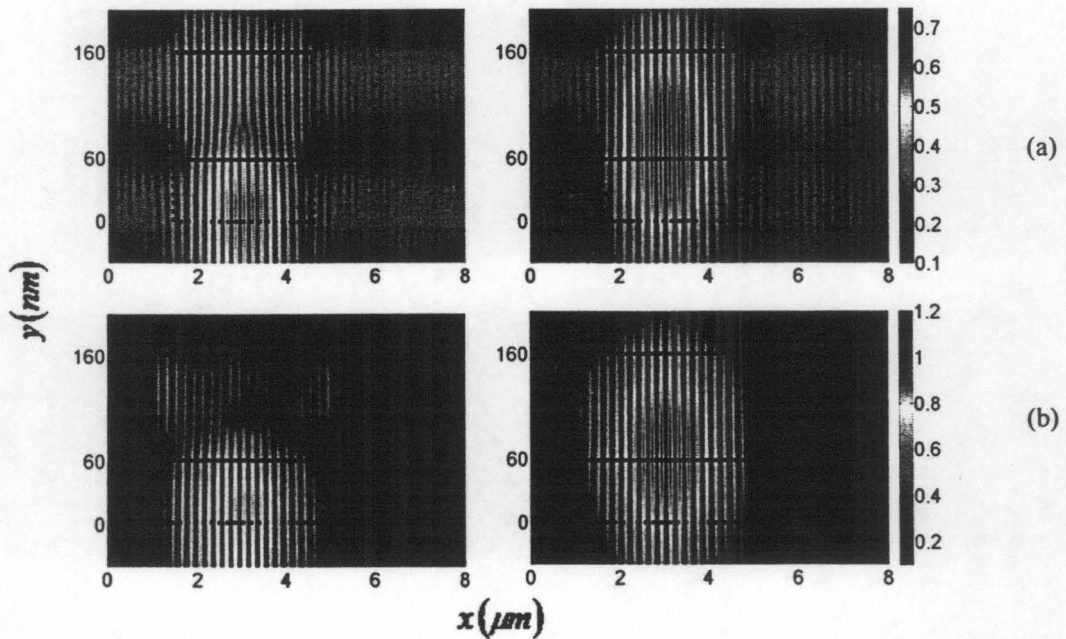


Fig. 3 LDOS contour of for upper (left panel) and lower (right panel) resonant for (a) $g = 100 \text{ nm}$ and $N = 14$, (b) for $g = 100 \text{ nm}$ and $N = 20$. Corrugated area is inside the box with solid-line boundary, while box with dotted-line boundary is the uncorrugated area.

The effect of groove depth on LDOS is shown in Fig. 3a for $g = 100 \text{ nm}$ with $N = 14$. It is demonstrated that deeper groove leads to higher LDOS with the different characteristics between upper and lower resonant are similar to the case given in Fig. 2. In the mean time, the LDOS can be further enhanced by increasing the number of teeth as exemplified in Fig. 3b for $N = 20$ and $g = 100 \text{ nm}$.

To characterize further the corresponding LDOS, we plot the highest value of LDOS at a specific point (r_0) along the line in the middle of the uncorrugated area for both resonant cases. According to Fig. 2 and Fig. 3, it should be noted that these values are not the highest LDOS of the corresponding asymmetric WG. However, it can be used to describe the dynamical characteristics of LDOS with respect to the variation of g and N .

Given in Fig. 4a is the variation of LDOS as a function of g at the specific aforementioned point. It is shown that for lower resonant case the related LDOS is increasing monotonously. But this is not the case for the upper case which have the maximum value at $g = 100 \text{ nm}$. This remarkable characteristic can be explained as a consequence of LDOS localization for the upper resonant case is mostly in the uncorrugated area, which is getting smaller for increasing groove depth. On the other hand, the variation of number of teeth N shares the same monotonous enhancement of LDOS between both resonant cases as expected.

5. SUMMARY

We have discussed the LDOS of an asymmetric waveguide at resonant states of photonic band gap edges. We observed different characteristics between LDOS at upper and lower resonant wavelengths. For upper resonant the corresponding

LDOS is localized in the uncorrugated area, while for the lower resonant is in both corrugated and uncorrugated areas. It is demonstrated that the larger number of teeth as well as deeper groove lead to the enhancement of LDOS.

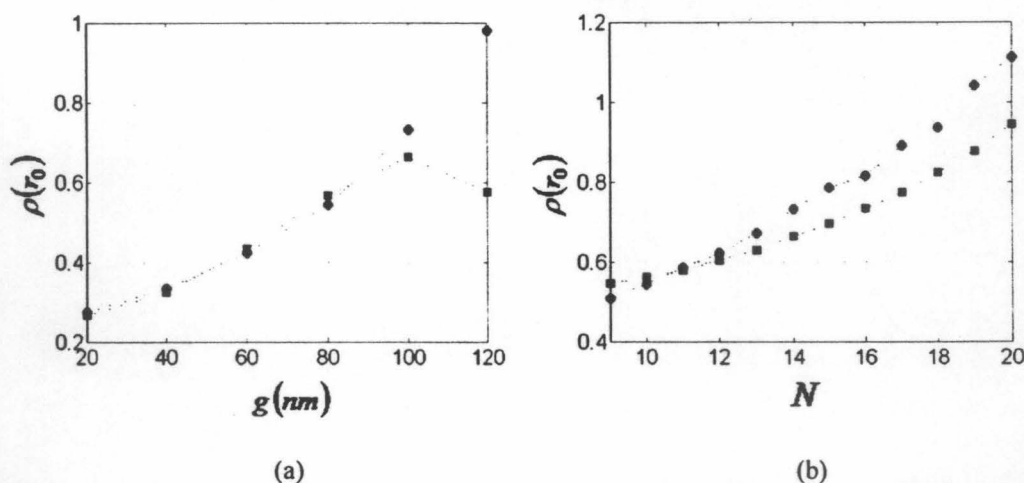


Fig. 4 Highest LDOS value at specific point along a line in the middle of asymmetric WG for (a) various g with $N = 14$, (b) various N with $g = 100 \text{ nm}$.

6. ACKNOWLEDGMENT

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